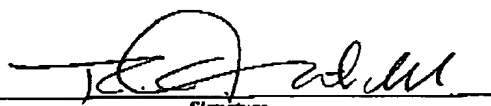



RECEIVED  
CENTRAL FAX CENTER

OCT 14 2005

MAIL STOP AF

TRANSMITTAL LETTER (General Patent Pending)			Docket No. 10932-US
In Re Application Of: Luc OUELLET, et al.			
Serial No. 08/833,711	Filing Date 13 April 2001	Examiner. MARKHAM, Wesley	Group Art Unit 1762
Title: METHOD OF DEPOSITING OPTICAL QUALITY SILICA FILMS BY PECVD WHILE CONTROLLING GAS PRESSURE			
<p style="text-align: center;"><b><u>TO THE ASSISTANT COMMISSIONER FOR PATENTS:</u></b></p> <p>Transmitted herewith is:</p> <p style="text-align: center;"><b>RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT MAILED 09/29/2005 CERTIFICATE OF TRANSMISSION VBY FACSIMILE</b></p> <p>In the above identified application.</p> <p><input checked="" type="checkbox"/> No additional fee is required. <input type="checkbox"/> A check in the Amount of _____ is attached. <input type="checkbox"/> The assistant Commissioner is hereby authorized to charge and credit Deposit Account No. _____ as described below. A duplicate copy of this sheet is enclosed.</p> <p><input type="checkbox"/> Charge the amount of _____ <input type="checkbox"/> Credit any overpayment. <input type="checkbox"/> Charge any additional fee required.</p> <p style="text-align: center;"> Signature</p> <p>Dated: October 13, 2005</p> <p>Richard J. Mitchell 34,519</p> <p>Marks &amp; Clerk Canada P.O. Box 957 Station B Ottawa, ON, K1P 5S7 Phone: (613) 236-9561</p> <p style="text-align: center;"> * 2 3 5 5 3 *</p> <div style="border: 1px solid black; padding: 5px;"><p>I certify that this document and fee being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.</p><p>_____ Signature of Person Mailing Correspondence</p><p>_____ Typed or Printed Name of Person Mailing Correspondence</p></div>			

P16A/REV01

RECEIVED  
CENTRAL FAX CENTER

OCT 14 2005

Appl. No. 09/833,711  
Amdt. dated Oct 12, 2005  
Reply to Notice of Sep 29, 2005

MAIL STOP AF

PATENT

Agent's Docket No. 10932-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/833,711 Confirmation No. 4962  
Applicant : Luc OUELLET et al  
Filed : 04/13/2001  
TC/A.U. : 1762  
Examiner : MARKHAM, Wesley D.  
Docket No. : 10932-US  
Customer No. : 23553

For: **METHOD OF DEPOSITING OPTICAL QUALITY SILICA FILMS  
BY PECVD WHILE CONTROLLING GAS PRESSURE**

October 12, 2005

Mail Stop AF  
Commissioner for Patents  
Alexandria, VA  
22313-1450

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT MAILED  
SEPTEMBER 29, 2005**

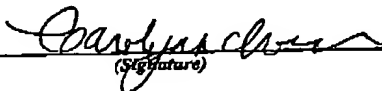
Sir:

In response to the Notice of Non-Compliant Amendment mailed September 29, 2005,  
applicants are submitting herewith a replacement page 5 of the response.

RECEIVED  
CENTRAL FAX CENTER

005

OCT 14 2005

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. 10932-US
Applicant(s): Luc OUELLET, et al.			
Serial No. 08/833,711	Filing Date 13 April 2001	Examiner MARKHAM, Wesley	Group Art Unit 1762
Invention: METHOD OF DEPOSITING OPTICAL QUALITY SILICA FILMS BY PECVD WHILE CONTROLLING GAS PRESSURE			
<p>I hereby certify that this <u>Response to Notice of Non-Compliant Amendment mailed September 29, 2005</u> (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademarks Office (Fax No. <u>571-273-8300</u>)</p> <p>on <u>14 October 2005</u> (Date)</p> <p><u>Carolynn Irvin</u> (Typed or Printed Name of Person Signing Certificate)</p> <p><u></u> (Signature)</p> <p>Note: Each paper must have its own certification of mailing.</p>			

P18/REV01